

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Initial Patent Application of

Masafumi Miyakawa et al.

Application No.: 10/507,245

Filing Date: September 10, 2004

Title: PRESSURE-SENSITIVE ADHESIVE FILM FOR THE SURFACE PROTECTION OF SEMICONDUCTOR WAFERS AND METHOD FOR PROTECTION OF SEMICONDUCTOR WAFERS WITH THE FILM

MAIL STOP RCE

Group Art Unit: 1711

Examiner: JEFFREY C MULLIS

Confirmation No.: 9077

PETITION FOR EXTENSION OF TIME

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

The following extension of time is requested to respond to the Official Action mailed May 17, 2006 for

Two Months to October 17, 2006

☒ \$ 450☐ \$ 225

- ☐ The shortened statutory period has been reset by an Advisory Action dated _____.
- ☐ An Extension fee in the amount of _____ is enclosed.
- ☐ Charge _____ to Deposit Account No. 02-4800.
- ☒ Charge \$450 to credit card. Form PTO-2038 is attached.

☐ An Extension fee in the amount of _____ is enclosed.

☐ Charge _____ to Deposit Account No. 02-4800.

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The Director is hereby authorized to charge any appropriate fees under 37 C.F.R. §§1.16, 1.17 and 1.21 that may be required by this paper, and to credit any overpayment, to Deposit Account No. 02-4800. This paper is submitted in duplicate.

Respectfully submitted,

BUCHANAN INGERSOLL & ROONEY PC

Date: October 13, 2006

By:

Robert G. Mukai
Robert G. Mukai
Registration No. 28531

P.O. Box 1404
Alexandria, VA 22313-1404
703 836 6620

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